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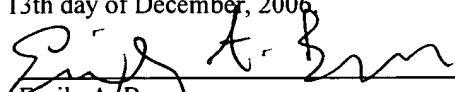
THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Yeshwanth Narendar et al.
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Confirmation No: 3742
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For: HIGH PURITY SILICON CARBIDE ARTICLES AND METHODS

Examiner: Karl E. Group
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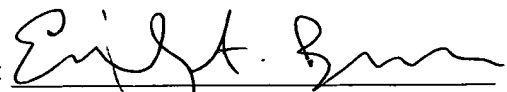
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- ☒ Amendment
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A check for \$180.00 is enclosed. If the fee required differs from the amount enclosed, the Commissioner is hereby authorized to charge any underpayment to or refund any overpayment to Deposit Account No. 50/2762.

Respectfully submitted,
Yeshwanth Narendar, et al., Applicants

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